

08-10-01

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08/09/01

Express Mail" mailing label number EL 746 760 452 USDate of Deposit 8/9/01Our File No. 9281-4140  
Client Reference No. CK US00016**PATENT APPLICATION TRANSMITTAL LETTER**

To the Commissioner for Patents:

Transmitted herewith for filing is the patent application of Akira Nakano and Tadahiro Ohmi for Plasma Processing Apparatus and System, Performance Validation System and Inspection Method Therefor.

Enclosed are:

- ☐ Preliminary Amendment with attached Appendix A
- ☒ 196 pages of application (including title page), 37 sheets of formal drawings and the following Appendices: n/a
- ☒ Declaration and Power of Attorney for Patent Application
- ☒ Assignment transmittal letter and Assignment of the invention to: Alps Electric Co., Ltd. and Tadahiro Ohmi
- ☒ Submission of Certified Copies of Priority Documents and certified copies of Japanese Application Nos. 2000-245347 and 2000-289488
- ☒ Information Disclosure Statement, PTO-1449, and reference A1

 J1050 U.S. PTO  
 09/25/99  
 08/09/01

Claims as Filed	Col. 1	Col. 2
For	No. Filed	No. Extra
Basic Fee	62-20	42
Total Claims	7-3	4
Indep. Claims		
Multiple Dependent Claims Present		

Small Entity	
Rate	Fee
	\$ 355
x\$9=	\$
x\$40=	\$
+ \$135=	\$
Total	\$

Other Than Small Entity	
Rate	Fee
	\$ 710
x\$18=	\$756
x\$80=	\$560
+ \$270=	\$
Total	\$2,026

\*If the difference in col. 1 is less than zero, enter "0" in col. 2.

- ☐ Please charge my Deposit Account No. 23-1925 in the amount of \$ \_\_\_\_\_. A duplicate copy of this sheet is enclosed.
- ☒ A check in the amount of \$2,026.00 to cover the filing fee is enclosed.
- ☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 23-1925. A duplicate copy of this sheet is enclosed.
- ☒ Any additional filing fees required under 37 CFR § 1.16.
- ☒ Any patent application processing fees under 37 CFR § 1.17.
- ☐ The Commissioner is hereby authorized to charge payment of the following fees during the pendency of this application or credit any overpayment to Deposit Account No. 23-1925. A duplicate copy of this sheet is enclosed.
- ☐ Any filing fees under 37 CFR § 1.16 for presentation of extra claims.
- ☐ Any patent application processing fees under 37 CFR § 1.17.
- ☐ The issue fee set in 37 CFR § 1.18 at or before mailing of the Notice of Allowance, pursuant to 37 CFR § 1.311(b).

Date

8/9/01

 Gustavo Siller, Jr.  
 BRINKS HOFER GILSON & LIONE  
 Registration No. 32,305

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Client Reference No. CK US00016

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
APPLICATION FOR UNITED STATES LETTERS PATENT

INVENTORS: Akira Nakano  
Tadahiro Ohmi

TITLE: Plasma Processing Apparatus and  
System, Performance Validation  
System and Inspection Method  
Therefor

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